



Attorney Docket No. 0756-7201

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Toru TAKAYAMA et al.

Serial No. 10/664,866

Filed: September 22, 2003

For: METHOD FOR MANUFACTURING
SEMICONDUCTOR DEVICE AND
HEAT TREATMENT METHOD

) Group Art Unit: 2818

) Examiner: Thao P. Le

) CERTIFICATE OF MAILING

) I hereby certify that this correspondence is
) being deposited with the United States Postal
) Service with sufficient postage as First Class
) Mail in an envelope addressed to:
) Commissioner for Patents, P.O. Box 1450,
) Alexandria, VA 22313-1450, on January 2,
) 2007.

Robert M. Stampu

AMENDMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 12 of this paper.

01/09/2007 ZJUHA1 00000014 10664866

03 FC:1202

450.00 0P